



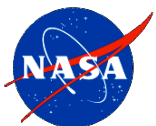
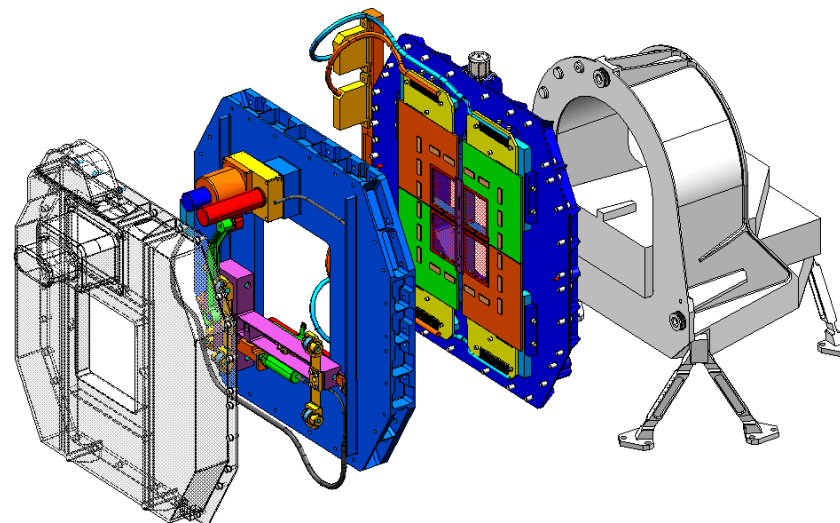
The Microshutter Array System:

Providing a Multi-Object Capability for the NIRSpec on JWST

**ELIXIR Summer School
Astrium - Ottobrunn**

2 June 2010

**Harvey Moseley
Microshutter PI
NASA/GSFC**





Ancient History



- **In 1996, Ed Weiler, then head of Astrophysics at NASA HQ, asked John Mather to initiate a study of a large telescope to be the successor Hubble.**
 - **HQ had solicited mission concept proposals that year, and no one had proposed to study a Hubble successor, so Weiler took it into his own hands.**
 - **John initiated some engineering studies, and organized the Ad Hoc Science Working Group (AHSWG), a group of scientists whose task was to develop a vision of what this Next Generation Space Telescope should be.**
- **After a couple of years of science and engineering studies, the AHSWG produced a document that largely set the direction for the observatory.**
- **The Near Infrared Spectrometer study set priorities on the characteristics of a the instrument needed for the high priority science identified by the team.**

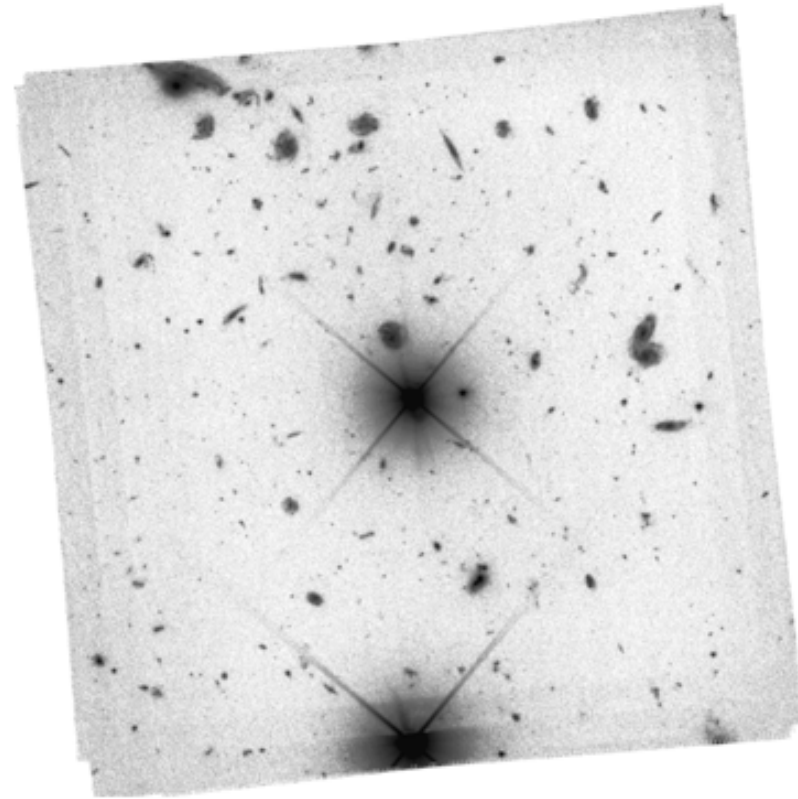




What Was Known about the High-z Universe?



- HDF had been obtained, and it was clear that a sensitive near IR telescope could probe deeply into the early universe
- A high sensitivity spectrometer was required to quantify the evolution of the early universe
 - Redshifts, Abundances, and Kinematics



STIS HDF-S image showing AB=30 galaxies





Derived Instrument Requirements



- *The requirements of a Near Infrared Spectrometer that could carry out the science reference missions set by the AHSWG were derived. They are:*
 - *R=100 spatially-integrated spectroscopy at maximum sensitivity with multiplexing performance secondary.*
 - *R=1000 spatially-integrated spectroscopy of multiple objects distributed over arcminute regions of sky with multiplexing performance paramount up to the expected number density of targets.*
 - *R=3000-5000 spatially-resolved 2-d spectroscopy at the diffraction limit of NGST of individual objects extended on the scales of a few arcsec.*
 - *R=1000 spatially resolved spectroscopy and R=3000-5000 spatially integrated spectroscopy.*





The Prime Directives



- 1. Ultimate point source sensitivity at $R \sim 100-1000$. This implies modest undersampling of the PSF.**
- 2. For $R \sim 1000$ and less, the need to cover the entire $1-5\mu\text{m}$ range for most objects although not necessarily simultaneously. For higher resolutions, a subset of the range is likely to be all that is required for a given object.**
- 3. Ability to acquire multiple spectra at especially $R \sim 1000$. DRM 7 drives this need most strongly. Acquiring spectra of adequate numbers of rare objects such as high- z AGN also drives the need for a large accessible field.**
- 4. Resolutions of 3000 and higher are important but are most important at wavelengths longer than 2.5 microns where there is no competition from the ground. There is no need for multiple object spectroscopy at these resolutions.**
- 5. At $R \sim 100-1000$, spatial resolution is not as important as sensitivity while at $R \sim 3000$ and greater, spatial resolution is important although the trade between full Nyquist sampling and somewhat lesser resolution needs to be made carefully.**





The Contenders

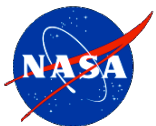
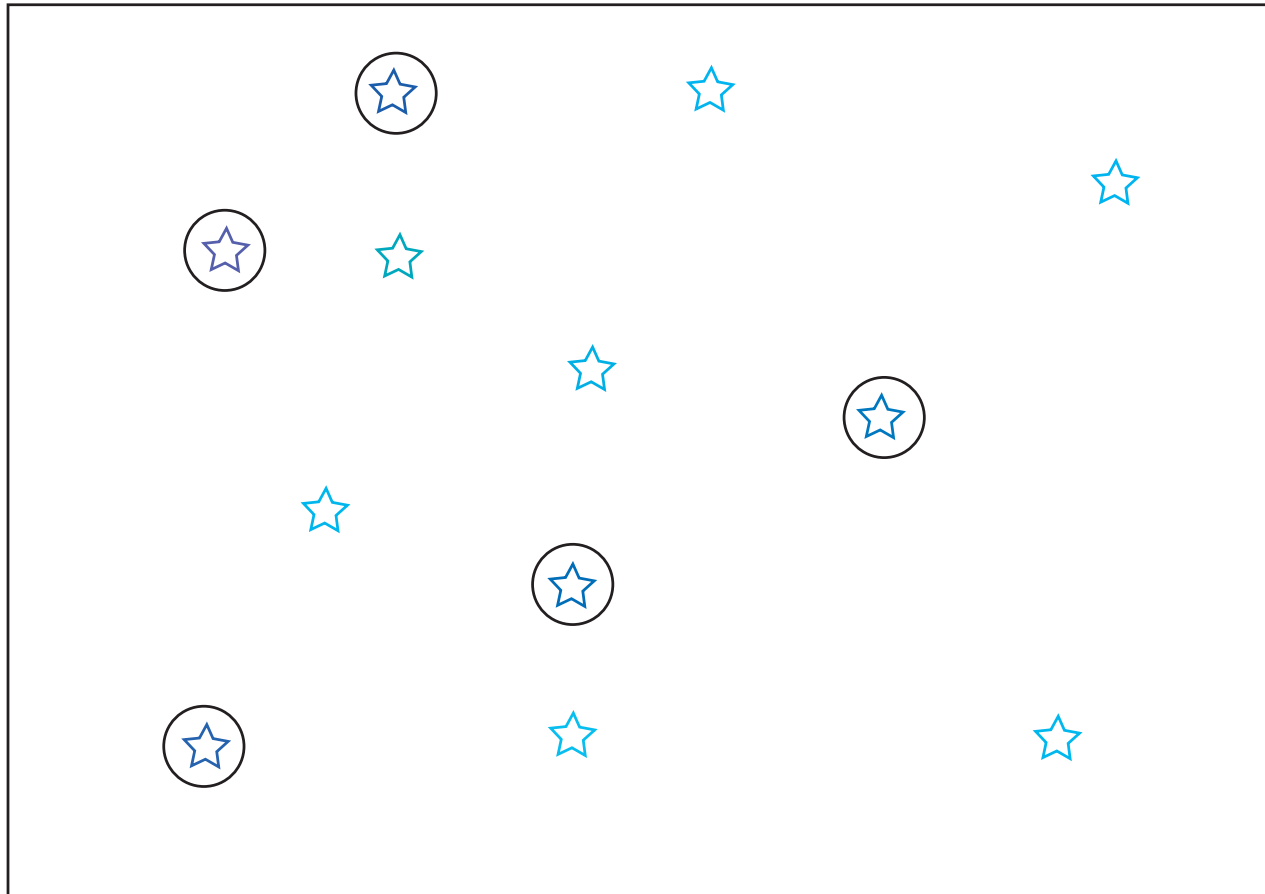


| Parameter | IFTS | Integral Field | MOS/MMA | MOS/slits |
|--------------------------|---|---------------------------------------|--|---|
| Point source sensitivity | Poor | Excellent | Excellent | Excellent |
| Mapping speed | Excellent | Good | Good | Good |
| Areal coverage | Excellent | Good | Excellent | Excellent |
| Chance of Serendipity | Excellent | Excellent | Poor-Good | Poor-Good |
| Throughput | Good | Good | Good | Good |
| Volume/mass | Poor | Good | Poor | Poor-Good |
| Operational Risk | Medium -- needs a mechanism | Low -- may not require any mechanisms | Low- Medium -- may require a mechanism | Low- Medium -- may require mechanisms |
| Operational Complexity | Medium -- low accuracy on pointing but high data volume | Low | High -- requires autonomous positioning of slits | High -- requires autonomous positioning of slits, mechanical slits most complex |
| Spectral Resolution | Broad range and easily changed | Fixed by design | Can be changed with grating selector | Can be changed with grating selector |



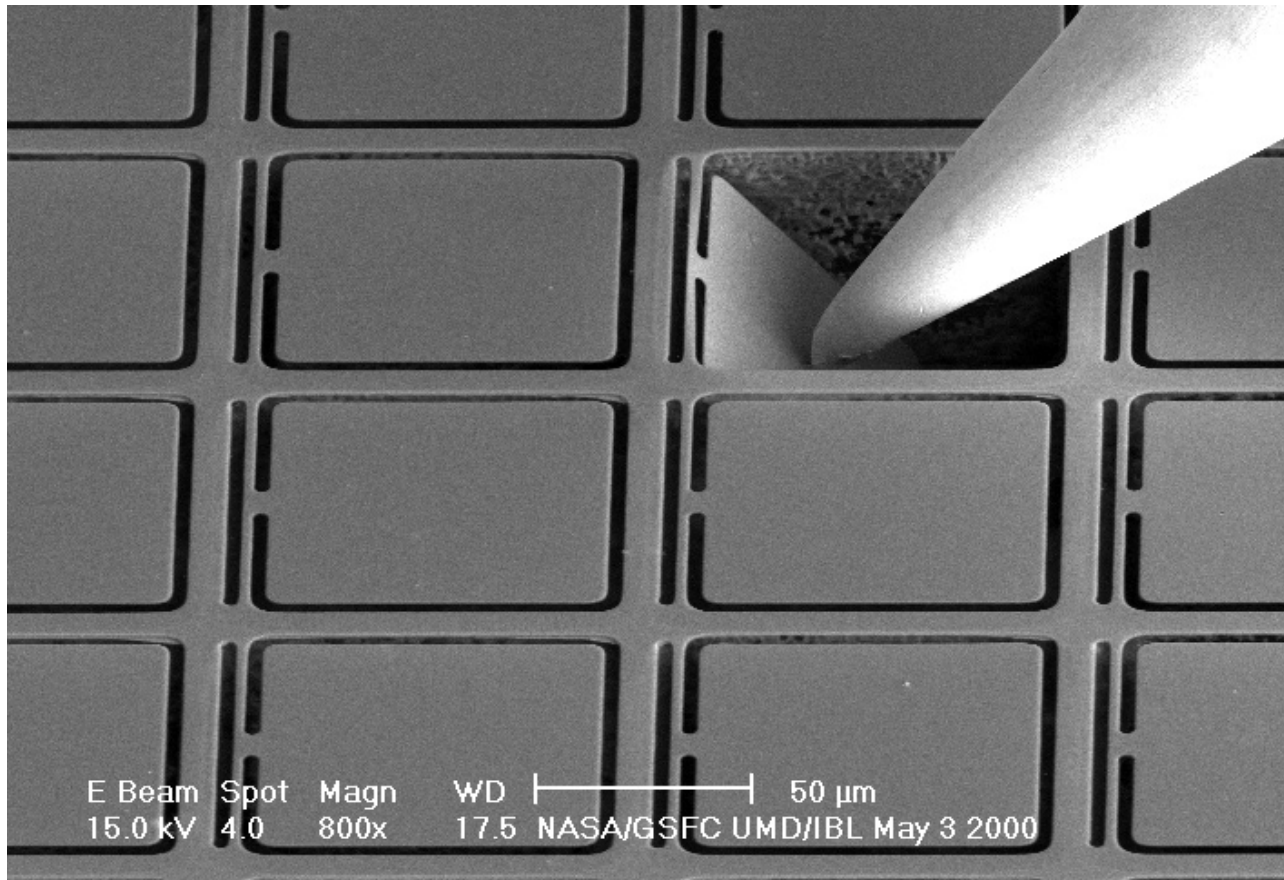


Drilled Plate MOS





Shutter and Hinge are Basis for Microshutter Array Design





Why Microshutters?



- High contrast
- High open efficiency
- No phase errors between open cells





Actuation Concept

- **Large displacement actuation done magnetically**
 - Requires magnet scan mechanism
- **Electrostatic Latching and Addressing**
 - Crosspoint addressing requires no on-chip active electronics





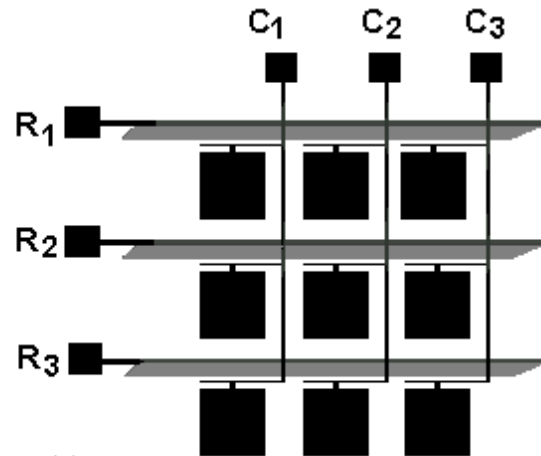
Required Functions

- **Shutter Operation**
 - **Magnetic actuation**
 - **Magnet, magnet coatings**
 - **Transport Stage**
 - **Electrostatic hold**
 - **Addressing electronics, vertical electrodes**
- **Optical performance demonstration**
 - **“On” transmission**
 - **“Off” transmission**



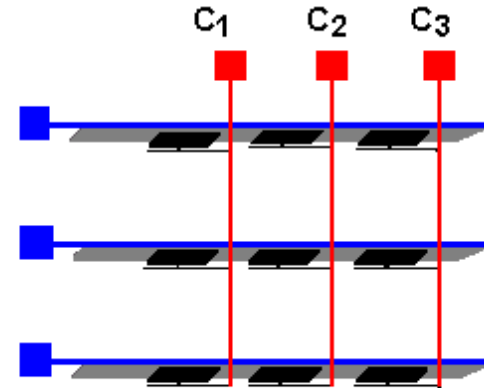


Principle of Operation



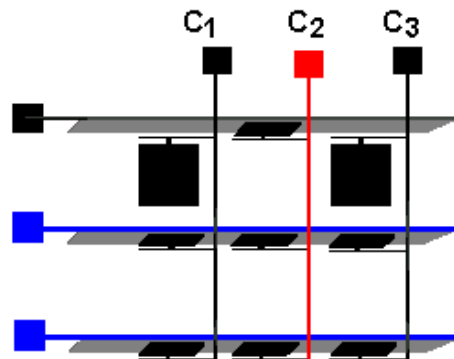
(a)

All Closed



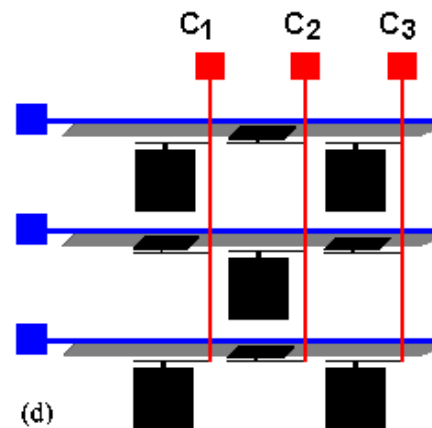
(b)

Actuate and Latch All



(c)

Release Selected Row 1

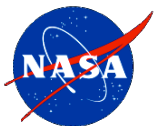


(d)

Hold Configuration

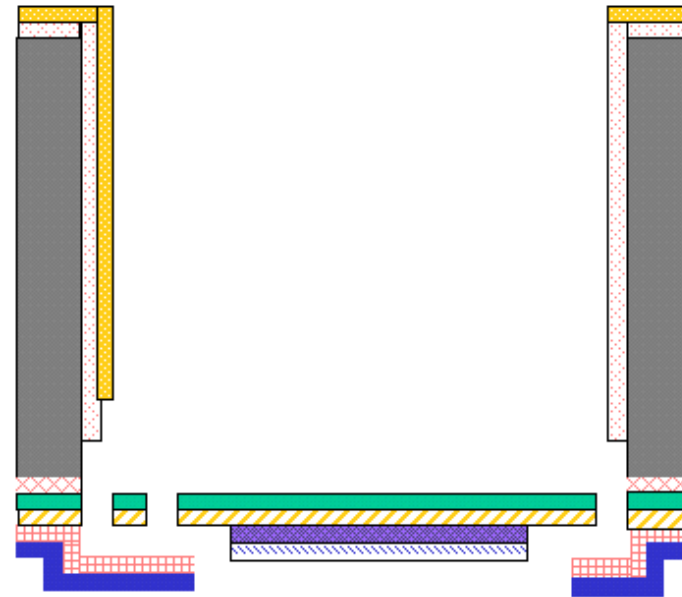
Release by Grounding Row











AND Column Addresses





Cross Section of Unit Cell

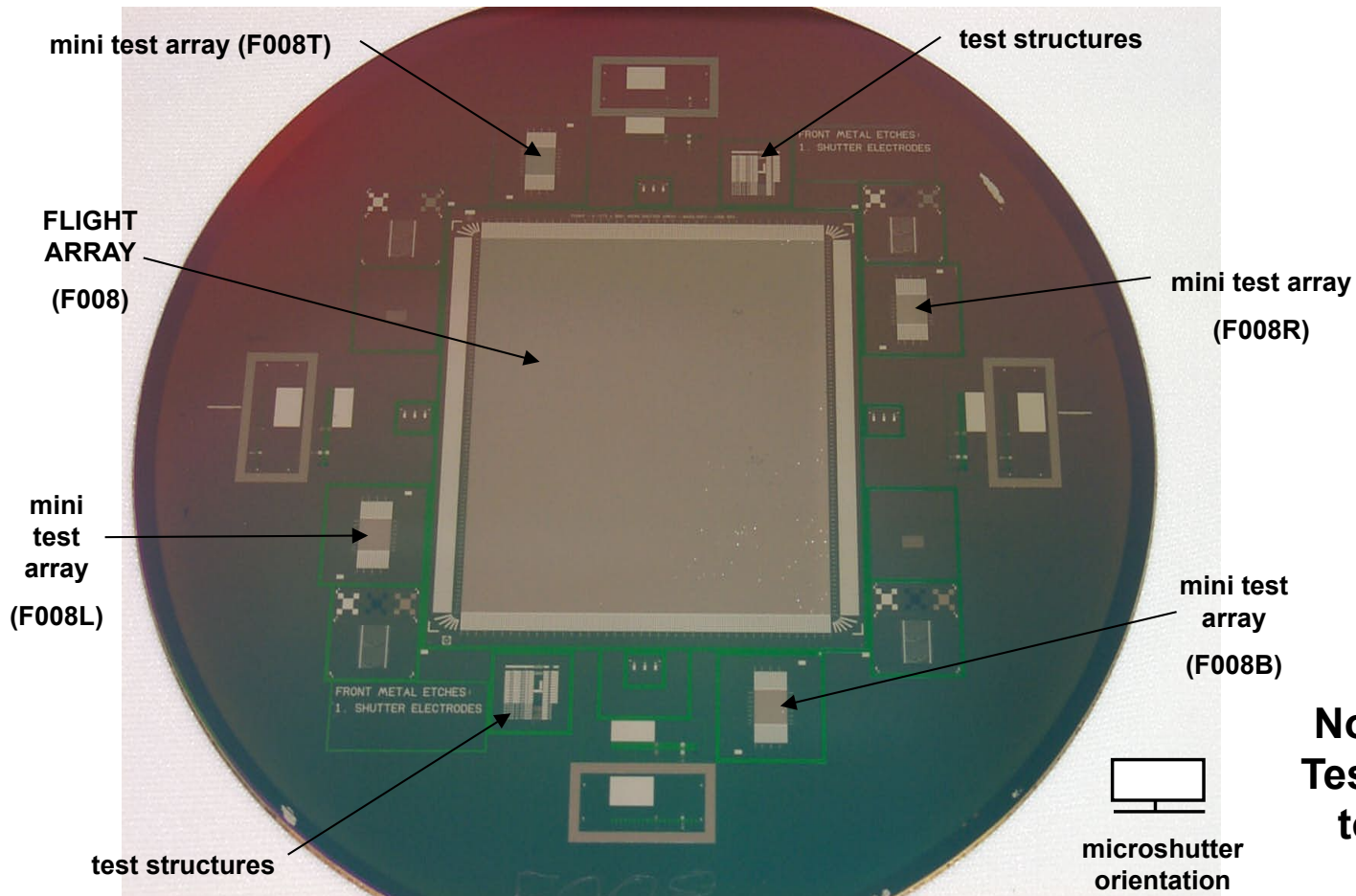


- | | | | |
|---|---|---|--|
|  | Light Shield: Aluminum |  | Magnetic Pad: CoFe |
|  | Support Grid: Silicon |  | Shutter Mechanical Layer: Silicon Nitride |
|  | Etch Stop: Silicon Dioxide |  | Vertical Electrode: Gold |
|  | Interconnect/Shutter Electrode: Gold |  | Vertical Electrode Insulator: Aluminum Oxide |
|  | Light Shield Insulator: Silicon Dioxide |  | Magnetic Pad Passivation: Aluminum |





Flight Wafer Layout



Note location of Mini Test Arrays in relation to FLIGHT ARRAY.





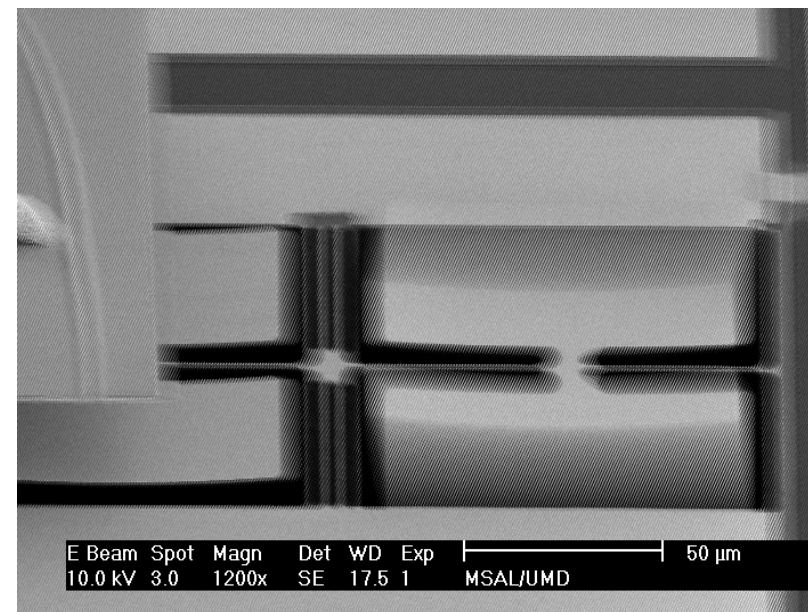
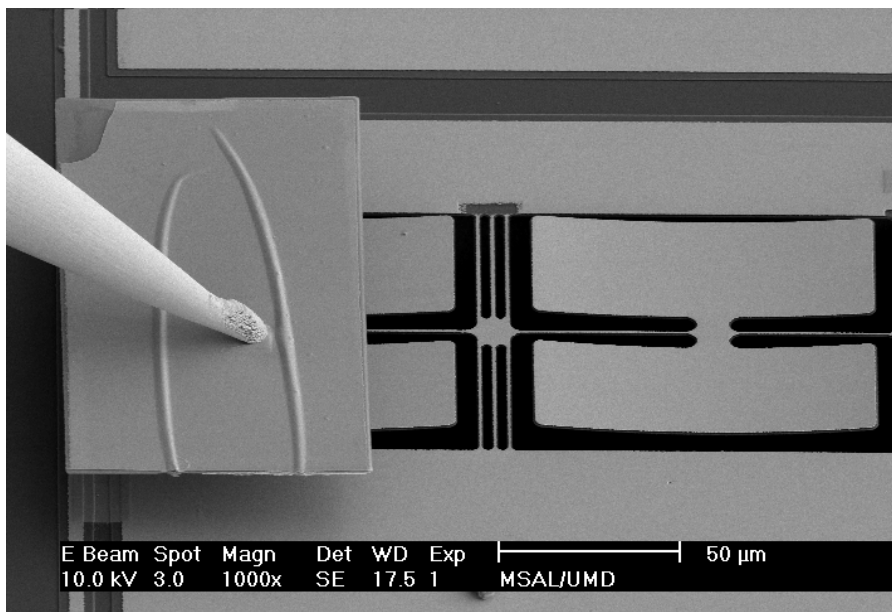
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MEMS SENSORS AND ACTUATORS LAB

Mechanical-Amplifier Device for Fatigue Testing



- A Testing Mechanical-Amplifier Device

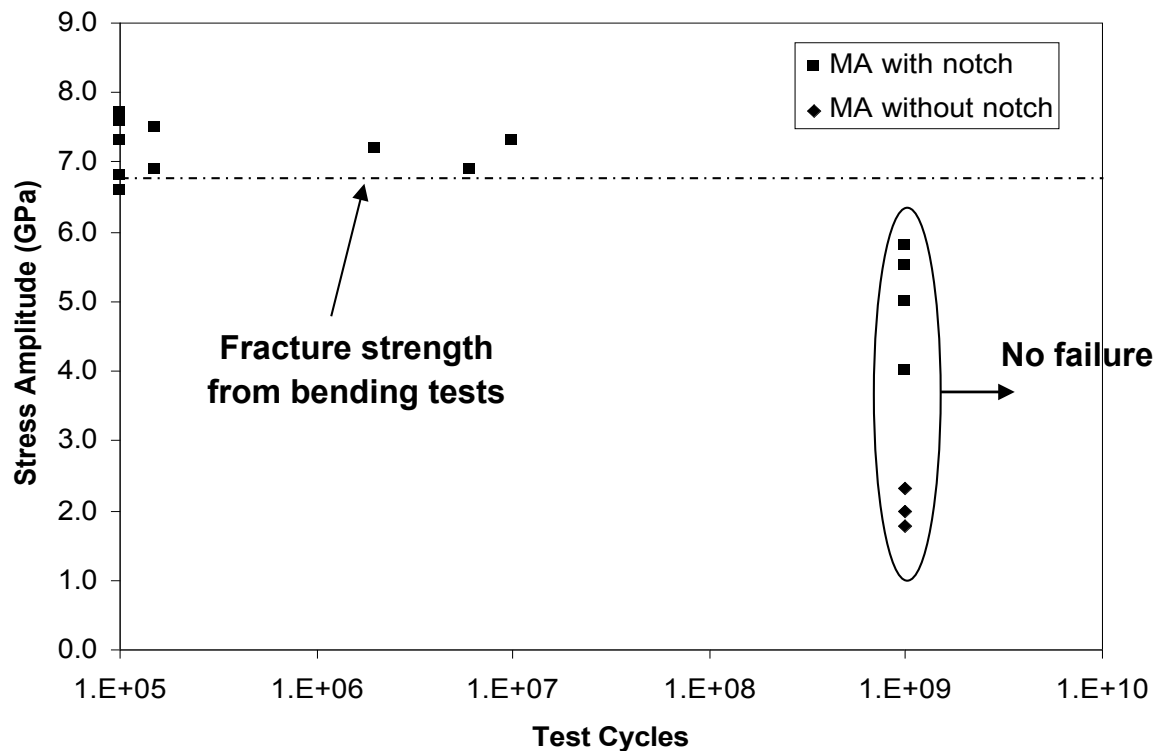




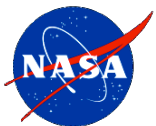
Mechanical-Amplifier Device for Fatigue Testing



• Test Results of Silicon Nitride Thin Films at Room Temperature

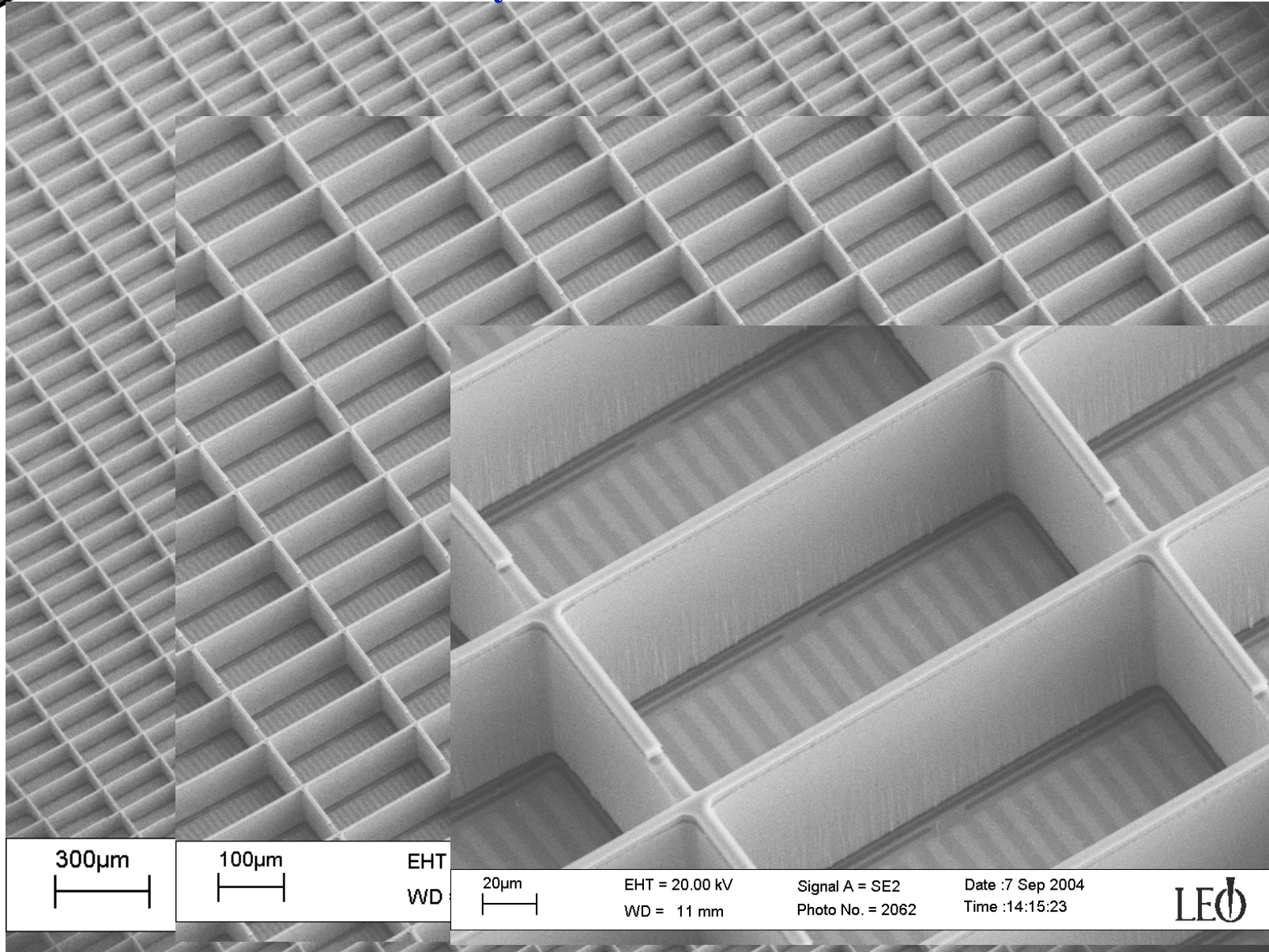


Stress-life testing data for silicon nitride thin films



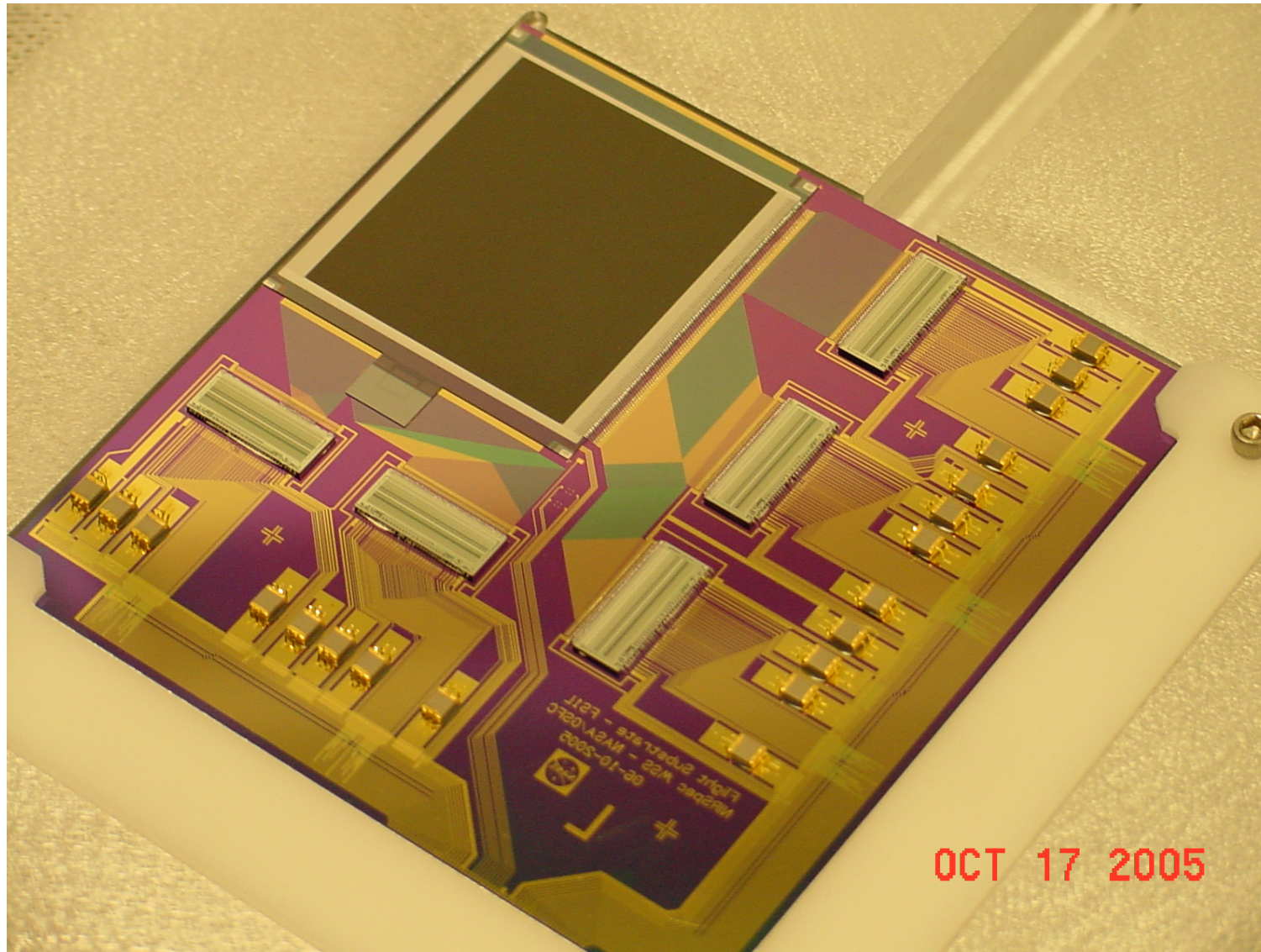


Continuation of 175x384 Array Fabrication



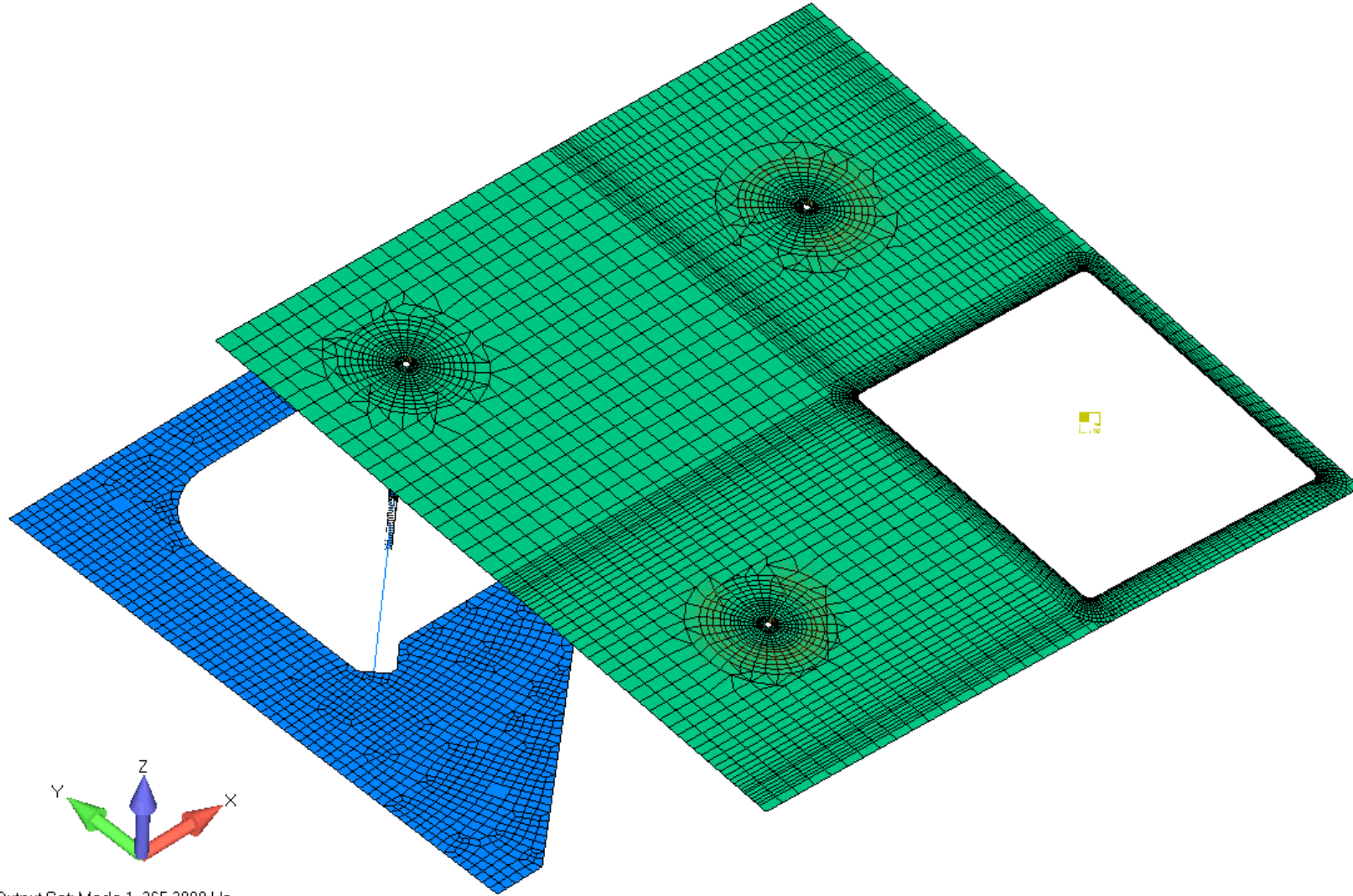


First fully populated substrate with array 015



OCT 17 2005



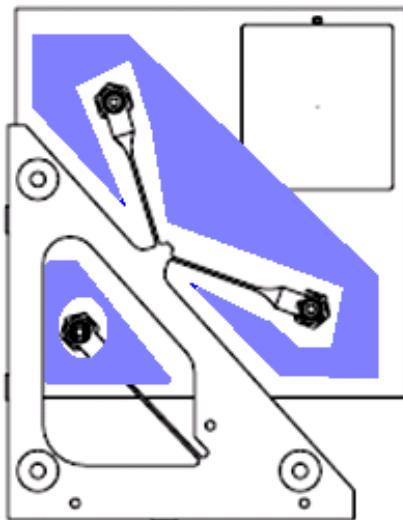


Output Set: Mode 1, 365.3099 Hz
Animate(18.43): Total Translation

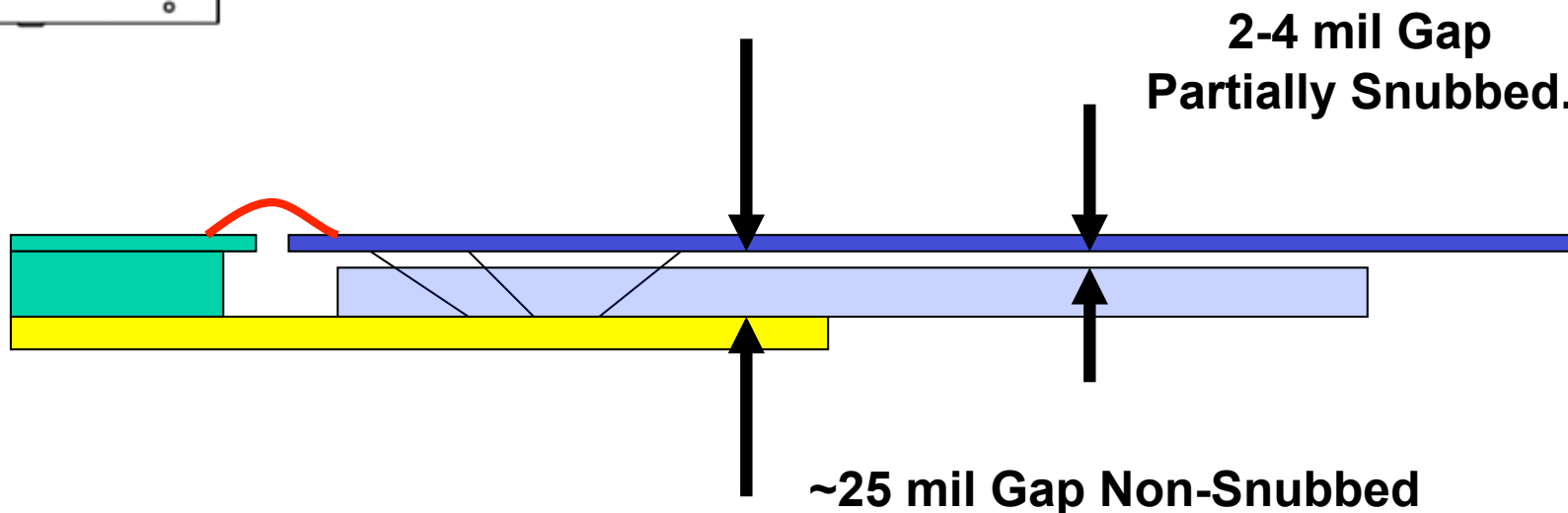




Snubber

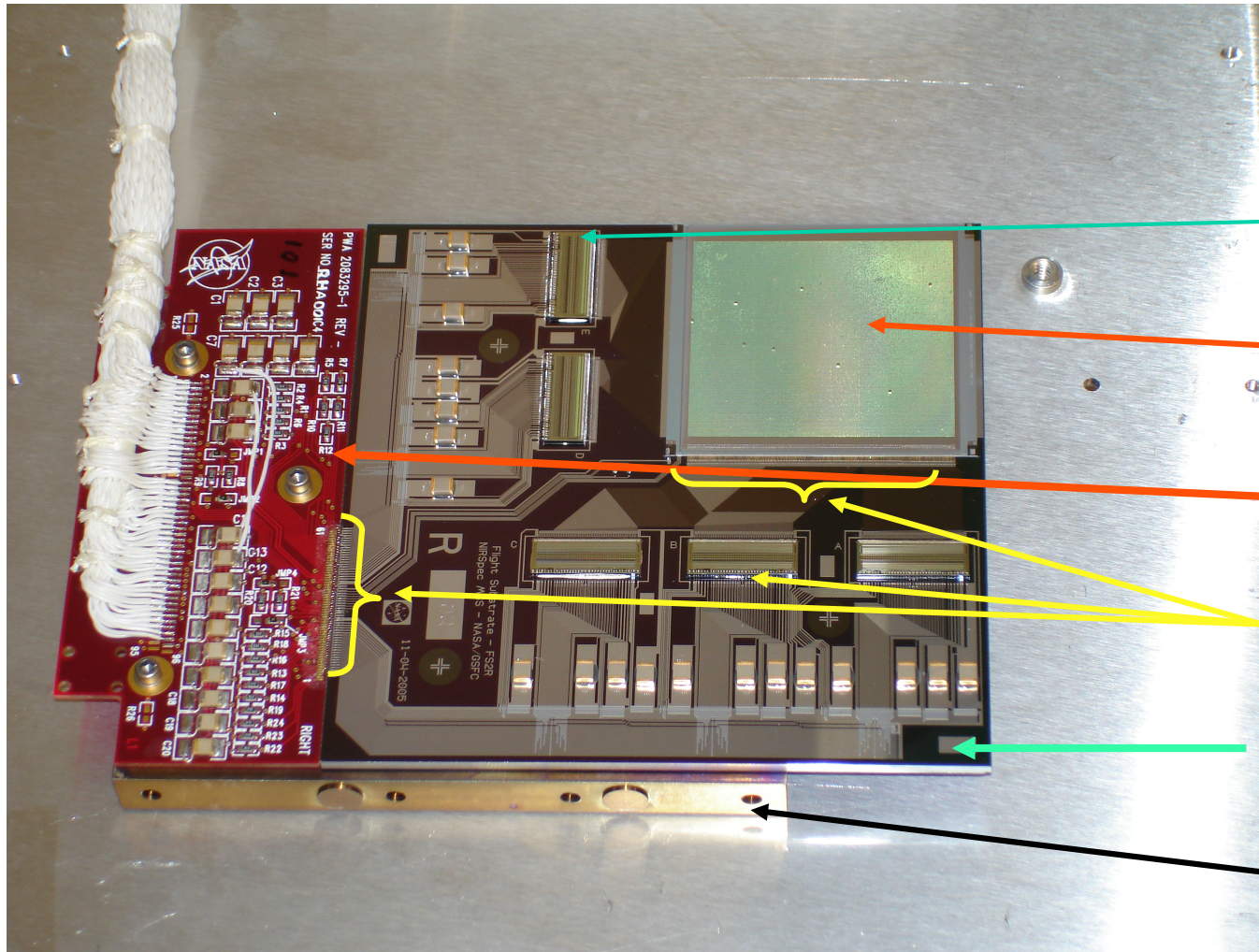


- **Wire bond failure on substrate side for all failures.**
 - Tests demonstrate a passing value for shock in 3-axis with a partially snubbed configuration, spacing up to 2 mils.
 - Tests confirm failure under two test configurations in the Z-axis, with a partially snubbed configuration, spacing 4 mils.
- **4 mil Physical Limit: Worst Case Scenario**





Substrate and Daughter Board Mounted on Flex Plate



HV 584

Microshutter Array

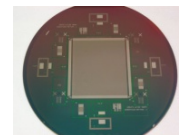
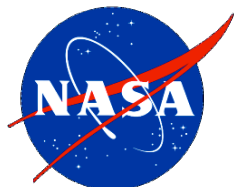
Daughter board

Wire bonds (>1,400)

Substrate

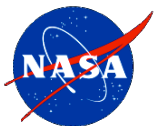
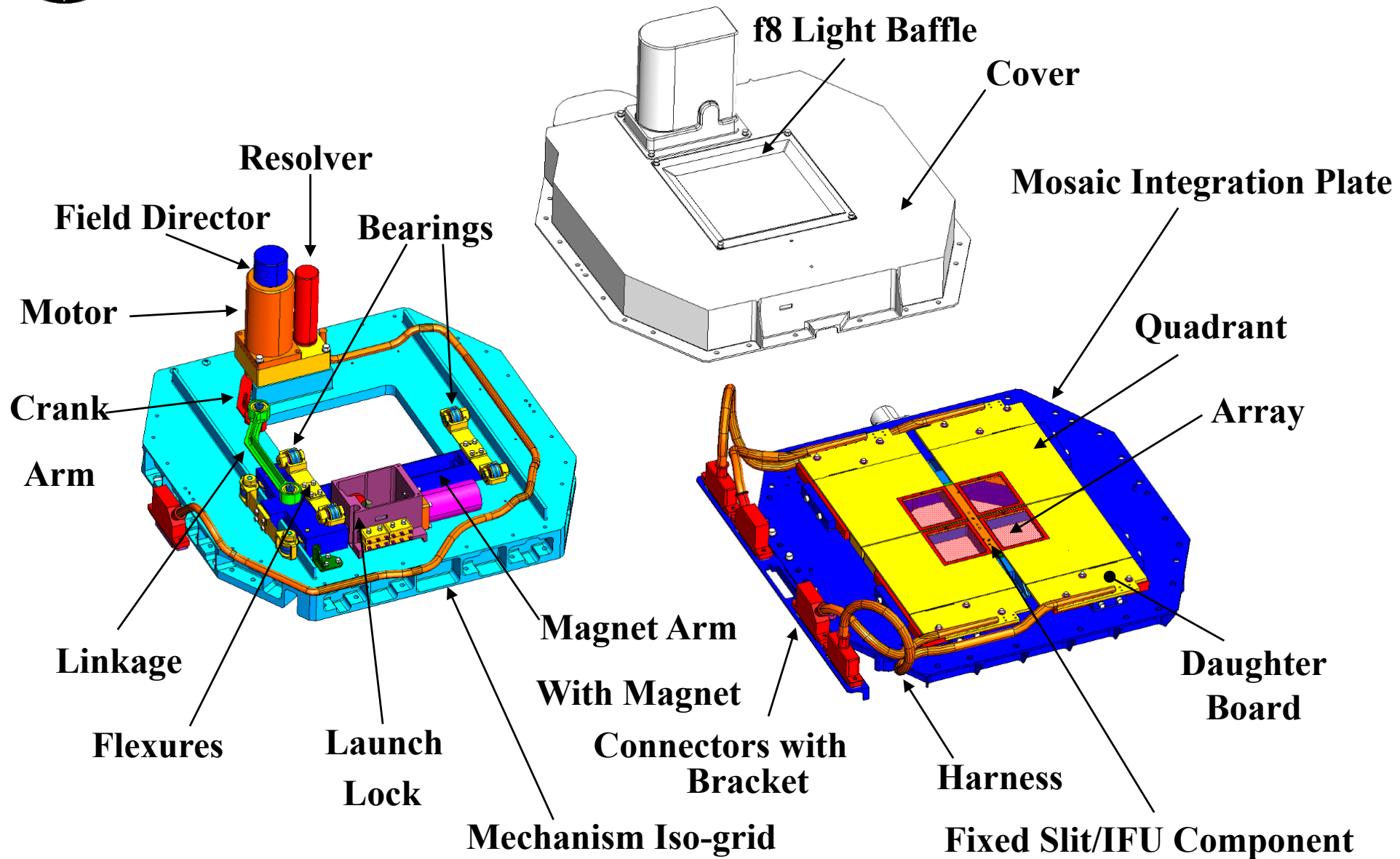
Flexure Plate

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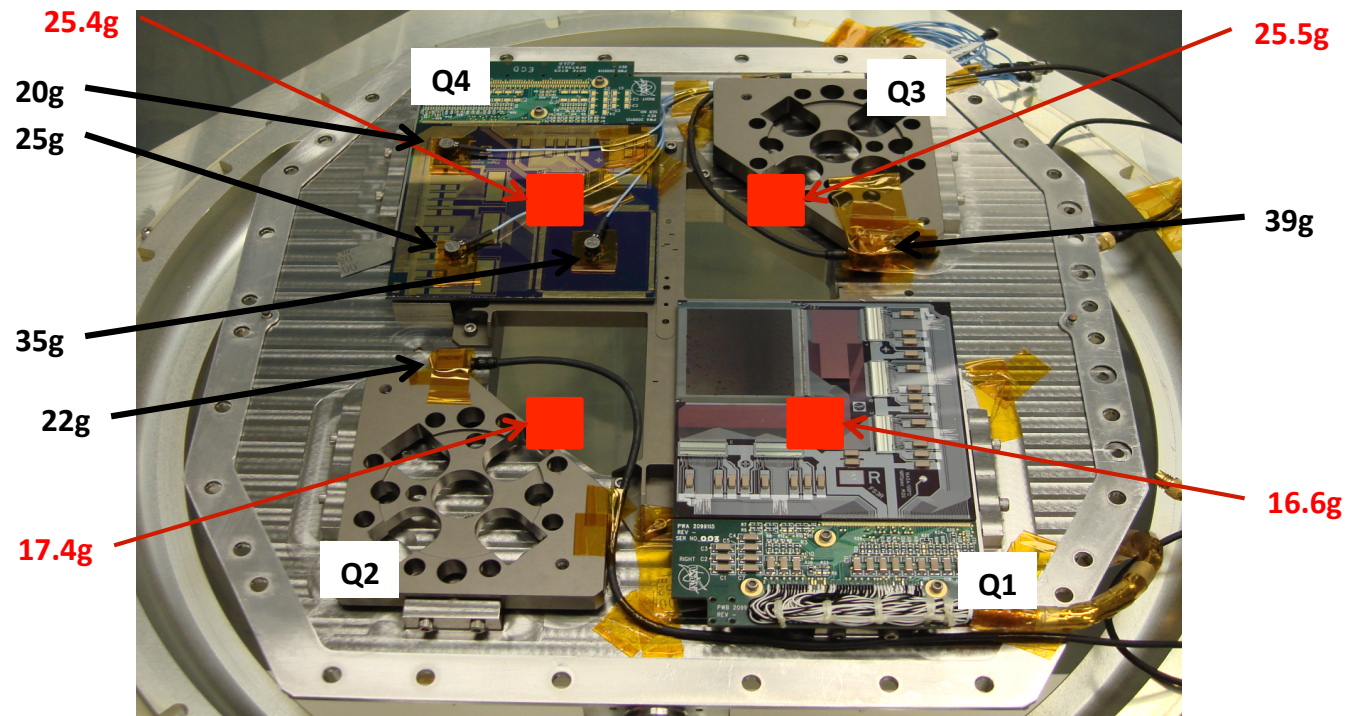


Transport Mechanism Layers





Vibration Test Data Showed Responses That Varied by Quadrant



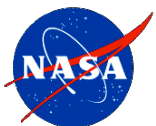
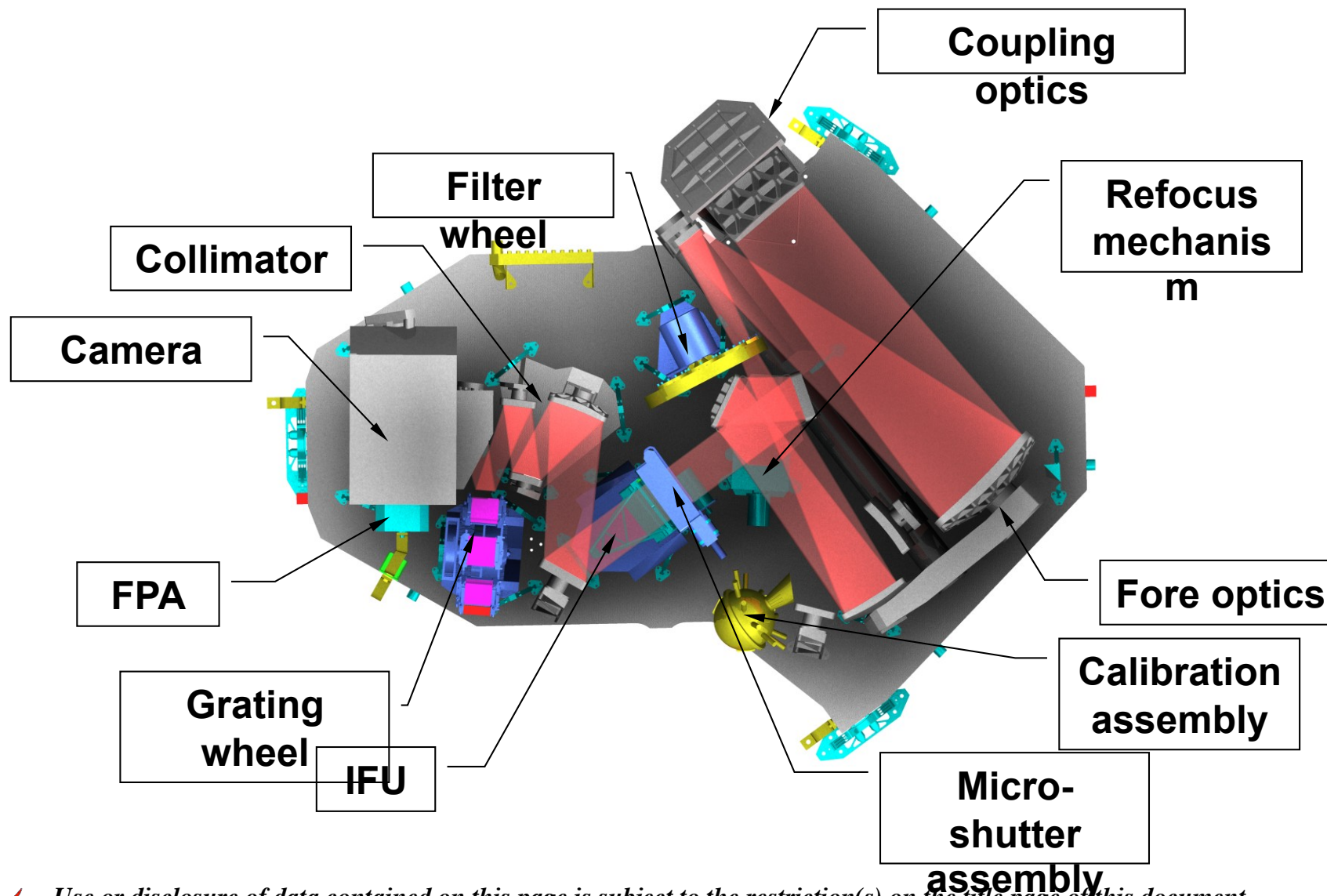
Accels shown in the picture correspond to the location of the accels during quadrant qual testing.

“Accels” drawn on the picture (red boxes) correspond to location of the accels for SM testing





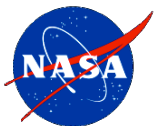
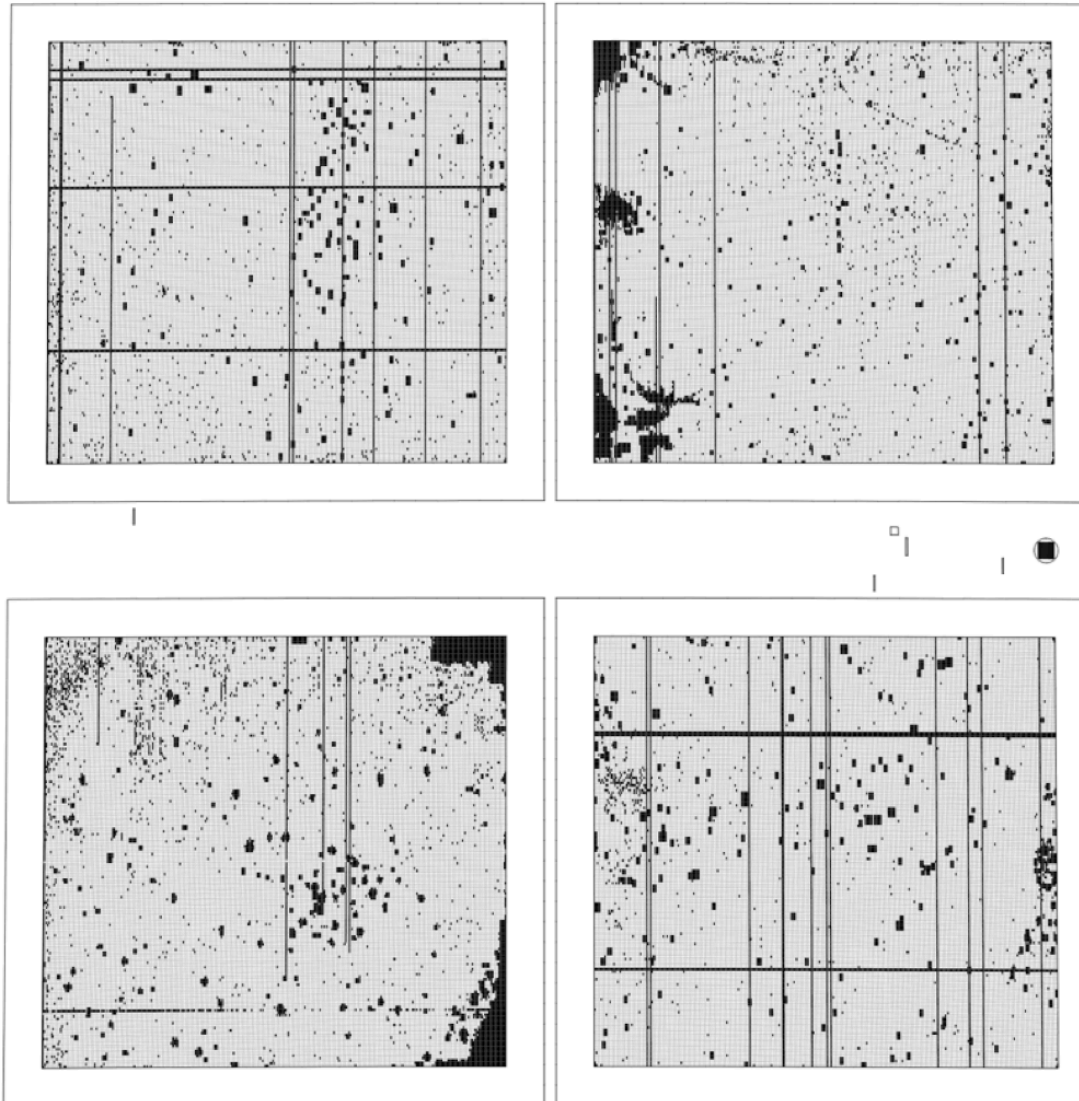
NIRSpec Instrument Layout



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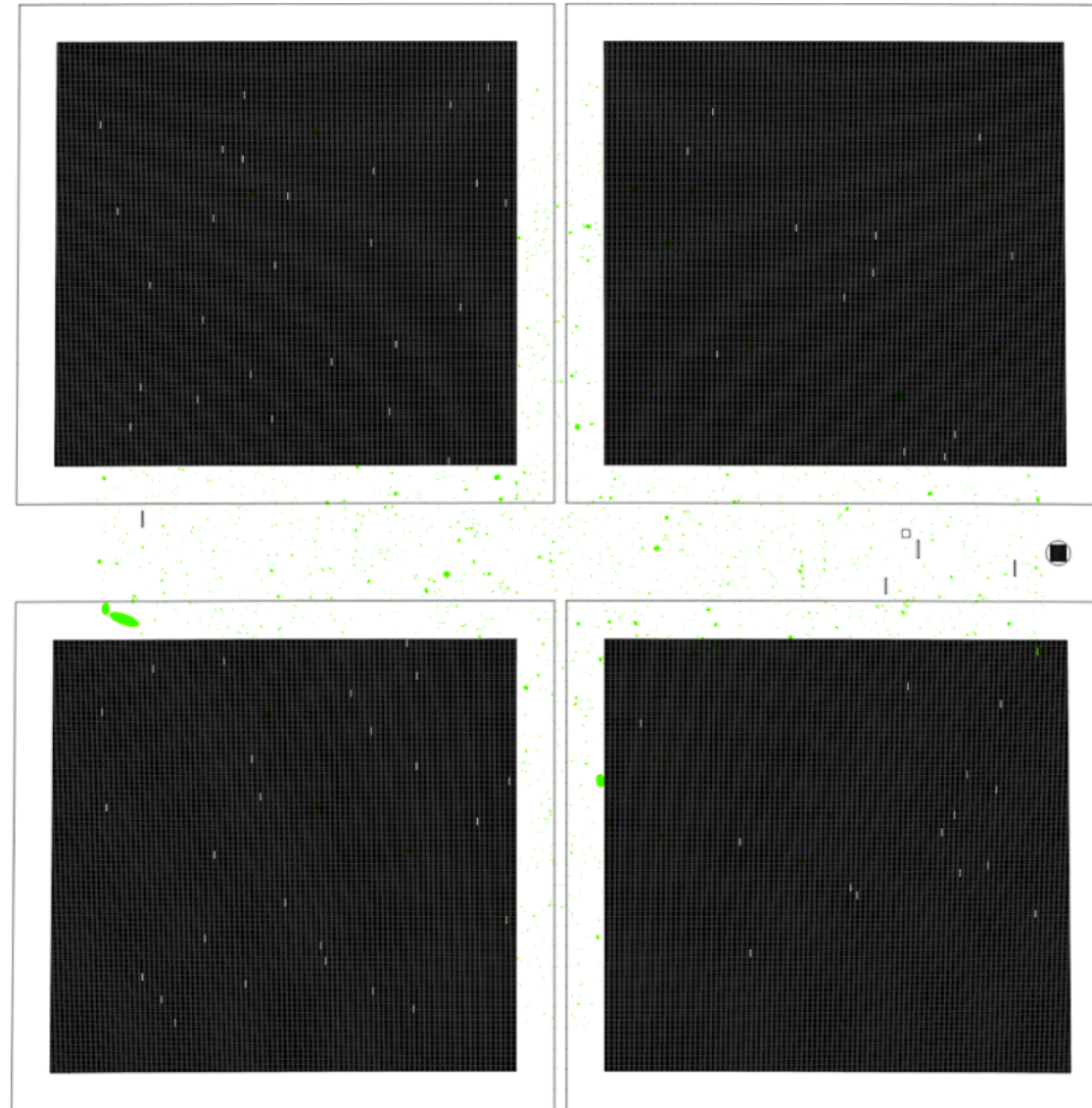


MSA Opens





Observing Configuration

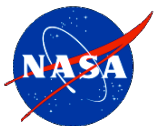
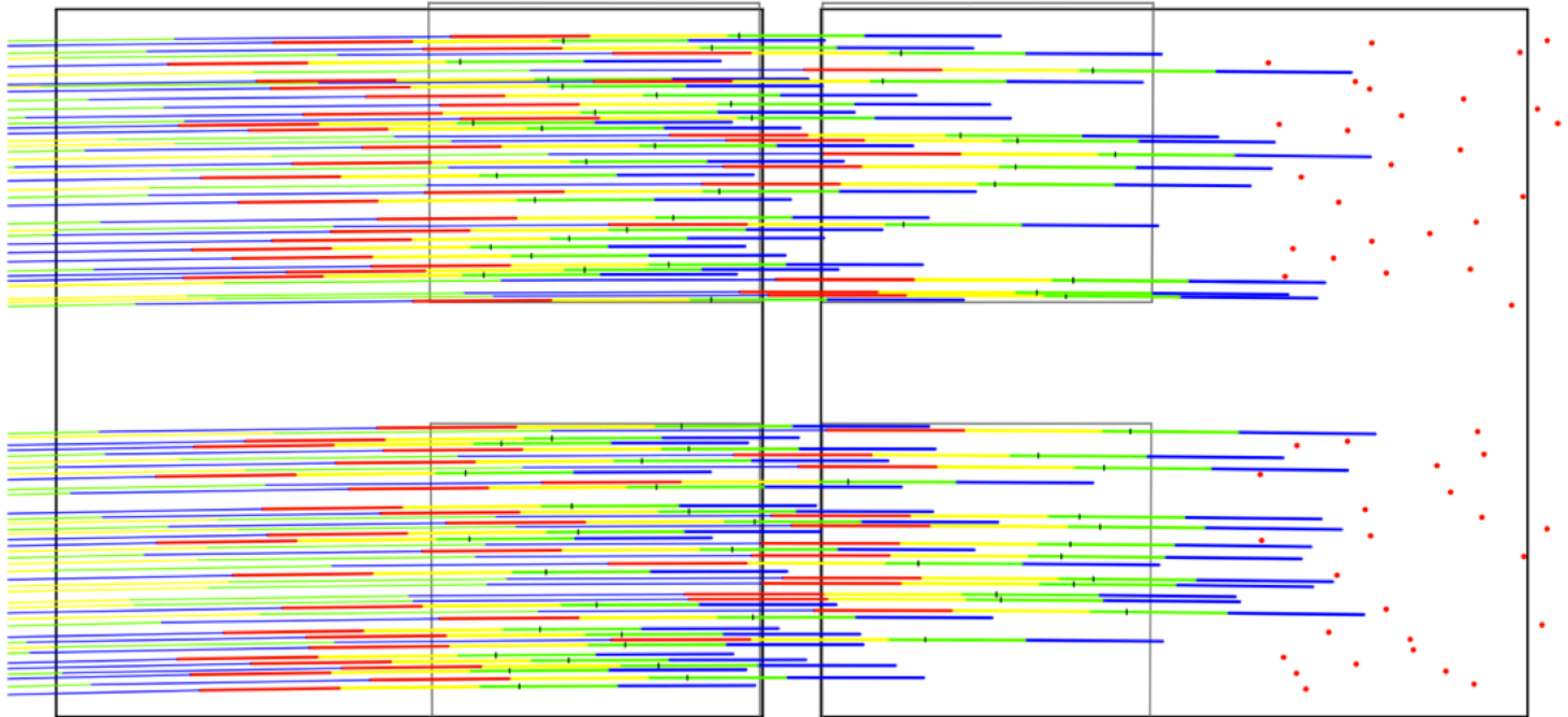


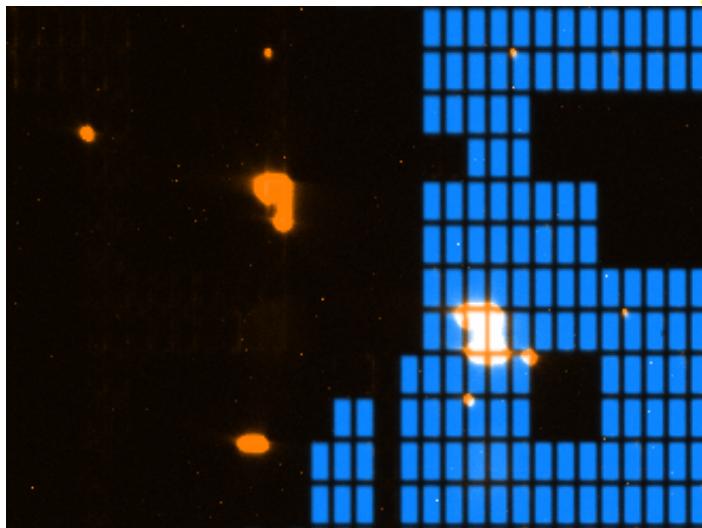
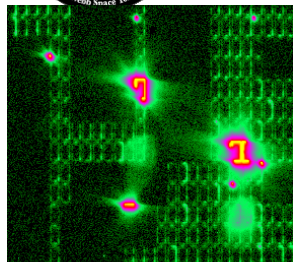


Lots of Spectra



R1000 Band II

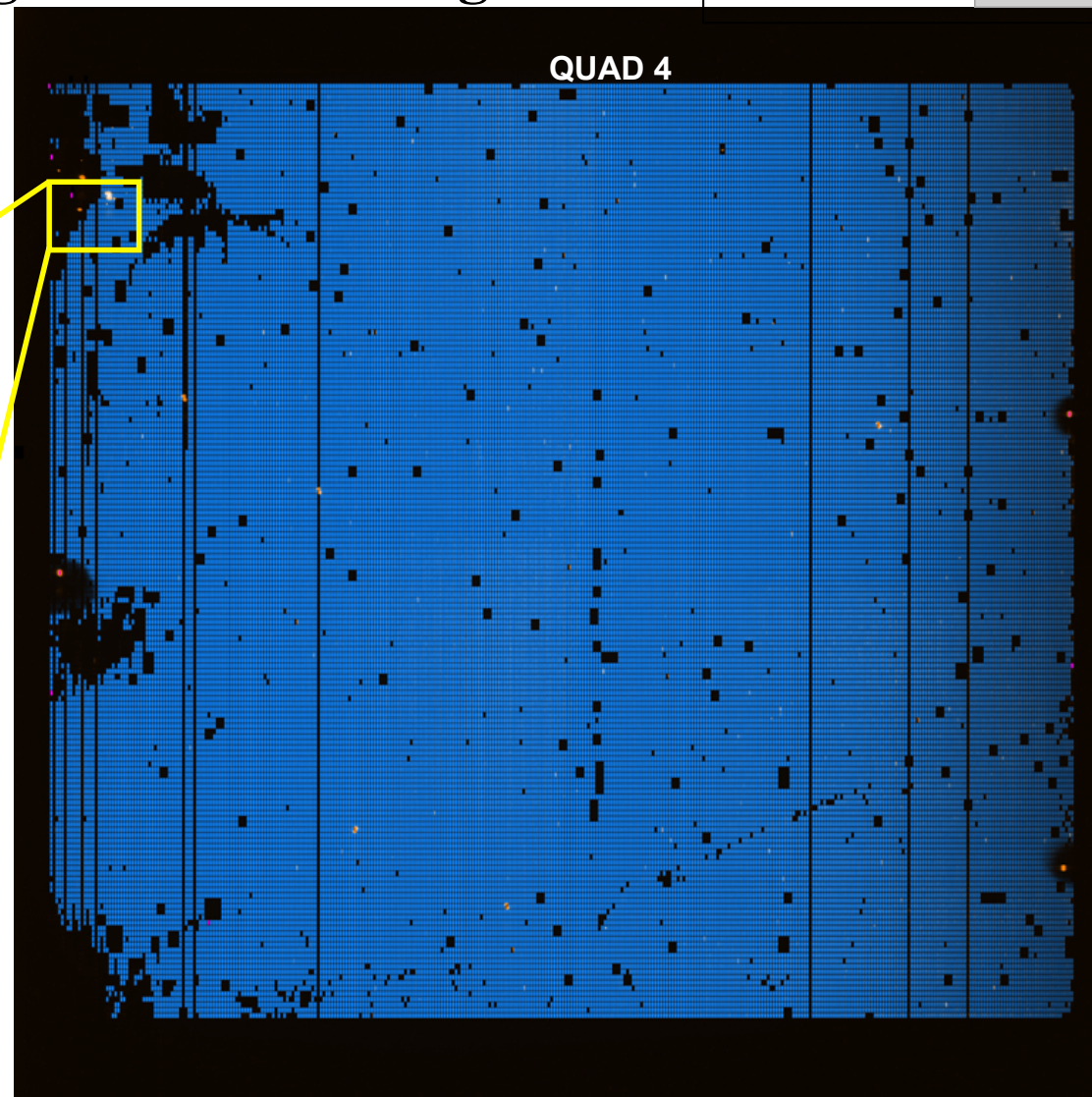




Failed Opens Light Shield Leakage

| Failure Count | | | |
|---------------|---|------|---|
| Dec. | | Apr. | |
| 0 | 0 | 0 | 0 |
| 0 | 8 | 0 | 8 |

- Very Low Contrast (<500)
- Localized to 14 shutters on 8 rows within enlarged area
- Masked during contrast test & escaped 2nd plugging
- Unchanged since last array test prior to MSA integration



Q4: Blue for Open Shutters. Black for Failed Closed Shutters. Orange & White for light leaks.

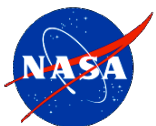




Quad History Summary



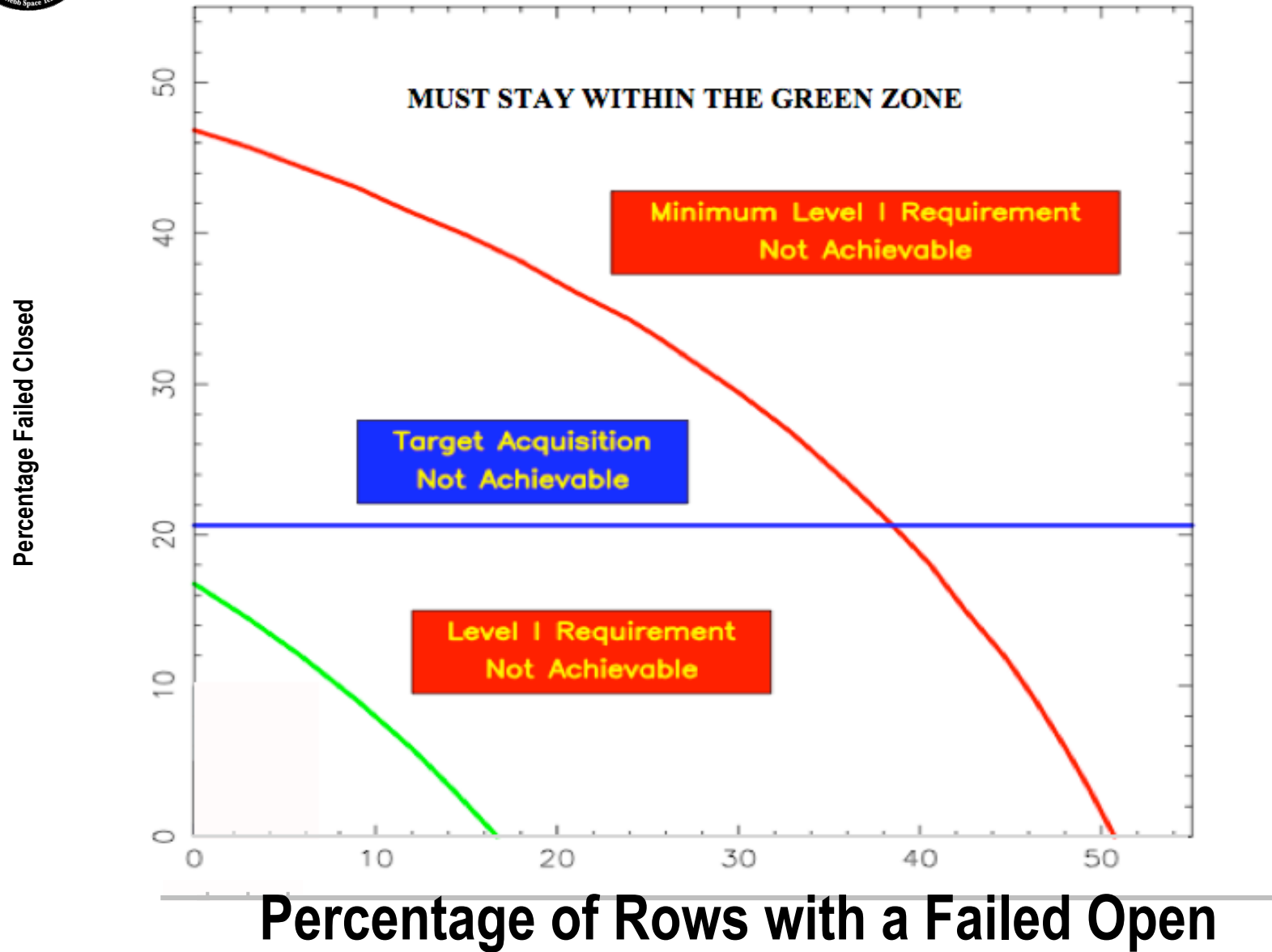
| Quad ID | Q1-52-102 | Q2-42-128 | Q3-26-106 | Q4-55-116 |
|-------------------------------------|---------------|---------------|----------------|---------------|
| Intermittent | 0 | 1 | 5 | 3 |
| Contrast < 500 | 0 | 1 | 0 | 9 |
| 500 < Contrast < 2K | 0 | 1 | 0 | 5 |
| Total F/O | 0 | 3 | 5 | 17 |
| # of F/O Columns Int. & Contrast | 0 | 3 | 5 | 15 |
| # of F/O Columns Contrast < 2000 | 0 | 2 | 0 | 12 |
| # of F/O Columns Contrast < 500 | 0 | 1 | 0 | 8 |
| Total F/C | 6274 | 6,103 | 11,519 | 5,399 |
| Avg. Visible Contrast | 42,458 | 78,000 | 120,000 | 71,000 |
| H Band IR | 13,439 | 13,000 | 16,600 | 7,627 |



ELIXIR Summer School



The Jakobsen Chart

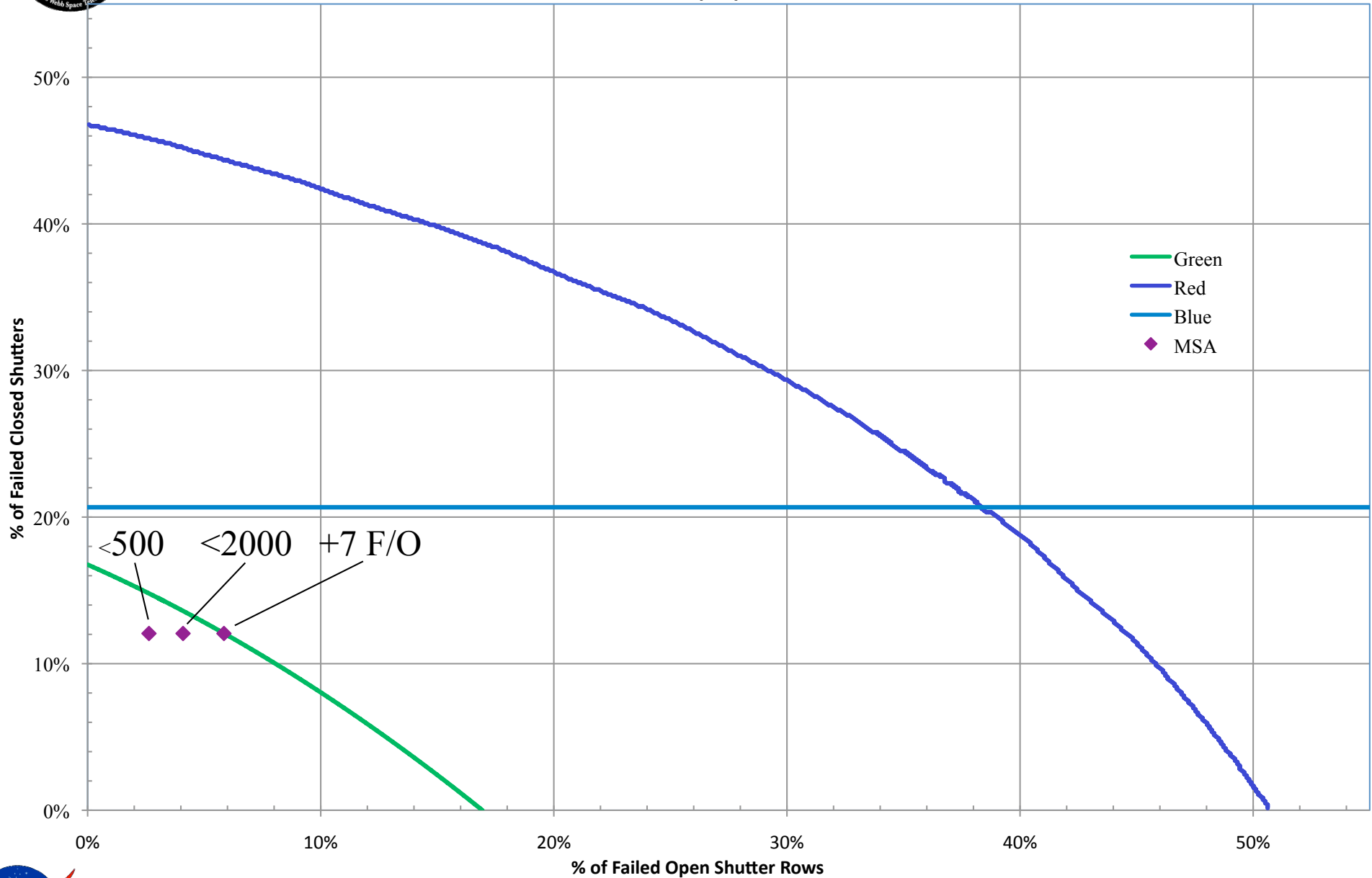




Failed Open-Failed Closed Requirements



MSA 5/12/2010





The Present



- **Flight Unit is assembled and is in performance testing**
- **Delivery of the system to Astrium is in the near future – JWST project says it come on June 17, no matter what.**
- **The most frightening part of the project is ahead – waiting for 5 years with only limited test opportunities**
- **If we can maintain the present performance during this time, NIRSpec, with its microshutters, will be a remarkable and unprecedented tool for science.**

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